



Gp/2882

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:
Gueorgui Gueorguiev

) Group Art Unit
) 2882

Serial No.: 09/709896
Filed: 11/13/00
For: Irradiation System and Method
Using X-ray Reflector and
Gamma Ray Reflector

) Examiner:
) Elizabeth M. Gemmell
)
)
)

Assistant Commissioner for Patents
Washington, D.C. 20231

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MAR 13 2002

Technology Center 2100

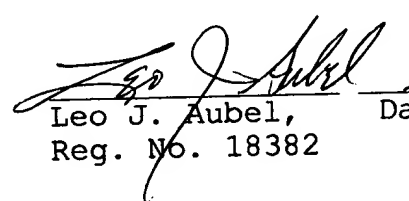
Communication

Dear Sir:

The subject application has been allowed.

A copy of an "Assignment of Application" form executed on
30 July 2001 by the inventor to Rad Source Technologies Inc.,
assignee of Largo Florida is enclosed for the record.

Respectfully submitted,

 2/14/02
Leo J. Aubel, Date
Reg. No. 18382

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